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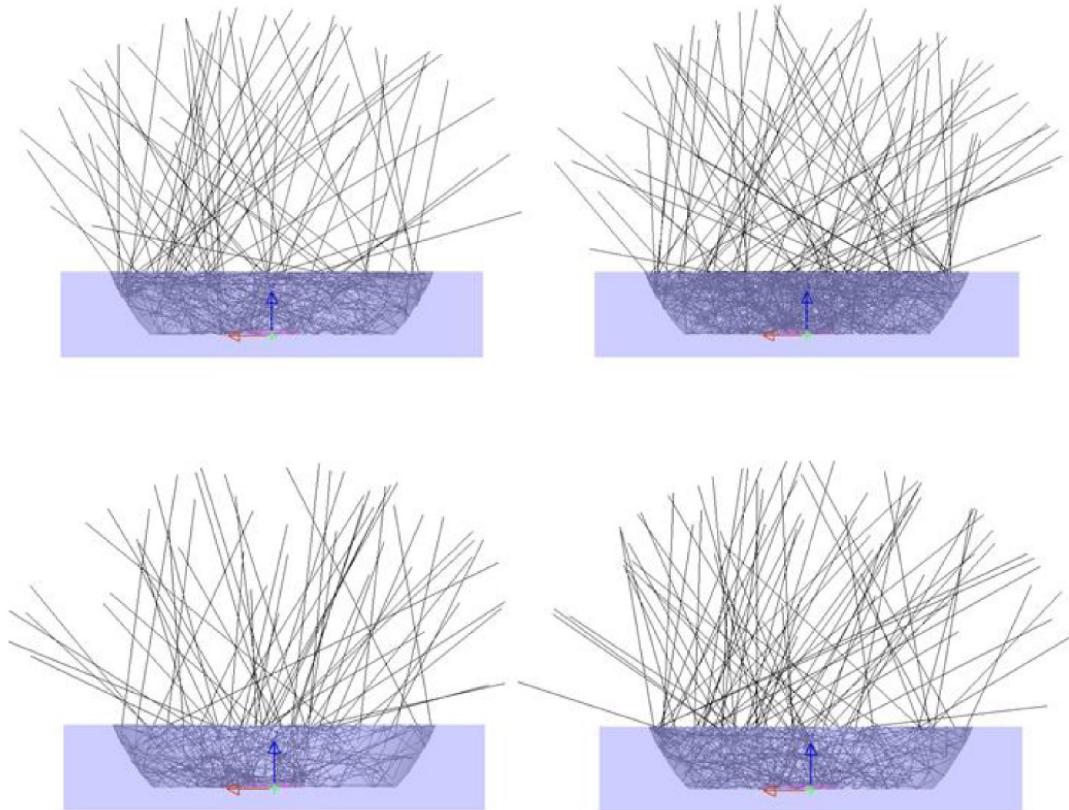
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Cover art from: "Investigation of Light Extraction by Refractive Index of an Encapsulant, a Package Structure, and Phosphor," by Jae Pil Kim and Sei-Wook Jeon (pp. 1815–1819, Fig. 8).



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